



RESPONSE UNDER 37 C.F.R. § 1.116

EXPEDITED PROCEDURE – Art Unit 1765

Attorney Docket No. 108298758US

Disclosure No. 03-0103.00/US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: WHONCHEE LEE

APPLICATION NO.: 10/783,763

FILED: FEBRUARY 20, 2004

FOR: **METHODS AND APPARATUSES FOR
ELECTROCHEMICAL-MECHANICAL
POLISHING**

EXAMINER: KIN-CHAN CHEN

ART UNIT: 1765

CONF. NO: 7390

Amendment Under 37 C.F.R. § 1.116

*reconsideration
request only.*

KCC

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated April 26, 2006 in the above-identified application. Please consider the application in light of the following remarks.

The pending claims are presented in the listing of claims beginning on page 2.